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APPLICATION NUMBER	FILING or 371(c) DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	TOT CLAIMS	IND CLAIMS
10/583,978	04/26/2007	2836	515	57901/N305	8	2

## CONFIRMATION NO. 8394

23363  
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## FILING RECEIPT

Date Mailed: 05/24/2007

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### Assignment For Published Patent Application

ADAPTIVE PLASMA TECHNOLOGY CORPORATION, Gyeonggi-do, KOREA,  
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**Power of Attorney:** The patent practitioners associated with Customer Number 23363

### Domestic Priority data as claimed by applicant

This application is a 371 of PCT/KR04/03387 12/22/2004

### Foreign Applications

REPUBLIC OF KOREA 10-2003-0094412 12/22/2003

**If Required, Foreign Filing License Granted:** 05/23/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/583,978**

**Projected Publication Date:** 08/30/2007

**Non-Publication Request:** No

**Early Publication Request:** No

**\*\* SMALL ENTITY \*\***

**Title**

Electrostatic Chuck And Chuck Base Having Cooling Path For Cooling Wafer

**Preliminary Class**

361

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